Kielce University of Technology

FACULTY OF MECHATRONICS AND MECHANICAL ENGINEERING

Annex 9
to the Rector's Ordinance No. 35/19
of 12 June 2019

COURSE SPECIFICATION

Course code	**M#1-S1-MiBM-301**
Course title in Polish	**Ochrona Własności Intelektualnej**
Course title in English	**Intellectual Property Protection**
Valid from (academic year)	**2019/2020**

GENERAL INFORMATION

Programme of study	**MECHANICAL ENGINEERING**
Level of qualification	**first-cycle**
Type of education	**academic**
Mode of study	**full-time**
Specialism	**all**
Department responsible	**Centre for Intellectual Property Protection**
Course leader	**Dr Magdalena Kotulska**
Approved by	

COURSE OVERVIEW

Course type	**basic**
Course status	**compulsory**
Language of instruction	English
Semester of delivery	**semester 3**
Pre-requisites	**None**
Examination required (YES/NO)	NO
ECTS value	**1**

Mode of instruction	**lecture**	**class**	**laboratory**	**project**	**seminar**
No. of hours per semester	**15**				

LEARNING OUTCOMES

Category of outcome	Out-come code	Course learning outcomes	Corresponding programme outcome code
Knowledge	W01	Has knowledge of the sources, structure, functions and basic institutions of intellectual property law. Can define and interpret the basic legal norms in the field of intellectual property legislation.	MiBM1_W07
	W02	He knows the rules of copyright protection and industrial property protection, in particular patent protection. He understands the importance of this field of law for the development of technology and modern economy.	MiBM1_W07
Skills	U01	Wykazuje umiejętność stosowania przepisów ustawy o prawie autorskim i prawach pokrewnych oraz ustawy – Prawo własności przemysłowej w typowych sytuacjach faktycznych.	MiBM1_U03
	U02	Demonstrates the ability to apply the provisions of the Act on Copyright and Related Rights and the Act - Industrial Property Law in typical situations.	MiBM1_U04
Competence	K01	It uses protected works in accordance with the law. Applies the principles of respect for copyrights in the implementation of creative works, including design and diploma works.	MiBM1_K02
	K02	Is able to cooperate and work in a group and act ethically within the designated organizational and social roles.	MIBM1_K04

COURSE CONTENT

Type of instruction*	Topics covered
lecture	1. The concept of intellectual property law and its place in the legal system • Internal structure of intellectual property law • The economic system and technical progress • Models of intellectual property protection • Sources of intellectual property law • • Intellectual property law functions
	2. Copyright • A work as an object of copyright • The problem of protection of technical projects and databases • Exclusions from protection • • Subject of copyright
	3. and 4. Copyright protection • Types, content and scope of copyright • Permitted use of protected works • Civil law protection of moral and property copyrights • • Criminal liability for infringement of copyright
	5. Plagiarism • The essence of plagiarism • Case studies • Legal liability of university students for plagiarism

	6. and 7. Patent law and utility model law - common issues • The Patent Office of the Republic of Poland - structure, tasks • The concept of invention and utility model • Prerequisites for patentability and protection • The content and scope of the patent and protection right for a utility model • Permitted use in patent law
	8. The procedure for applying for the protection of inventions and utility models • Submitting inventions and utility models • Examination of patent applications and granting protection titles • The role of a patent attorney in proceedings before the Polish Patent Office • Other objects of industrial property and their protection

ASSESSMENT METHODS

Outcome code	Methods of assessment *(Mark with an X where applicable)*					
	Oral examination	Written examination	Test	Project	Report	Other
W01			x			
W02			x	x		
U01			x			
U02			x	x		
K01				x		X
K02				x		x

ASSESSMENT TYPE AND CRITERIA

Mode of instruction*	Assessment type	Assessment criteria
lecture	non-examination assessment	*The pass mark is a minimum of 50% for the final test.*

OVERALL STUDENT WORKLOAD

ECTS weighting								
	Activity type	Student workload					Unit
1.	Scheduled contact hours	L	C	Lab	P	S	h
		15					
2.	Other contact hours (office hours, examination)	2					h
3.	**Total number of contact hours**	**17**					h
4.	**Number of ECTS credits for contact hours**	**0,7**					ECTS
5.	**Number of independent study hours**	**8**					h
6.	**Number of ECTS credits for independent study hours**	**0,3**					ECTS
7.	**Number of practical hours**	**2**					h
8.	**Number of ECTS credits for practical hours**	**0**					ECTS
9.	**Total study time**	**25**					h

10.	**ECTS credits for the course** *1 ECTS credit = 25-30 hours of study time*	**1**	ECTS

READING LIST

1. Adamczak A, du Vall M., (red.), *Ochrona własności intelektualnej*, UOTT UW, Warszawa 2010
2. Barta J., Markiewicz R., *Prawo autorskie i prawa pokrewne*, Wolters Kluwer, Warszawa 2019
3. Sieńczyło-Chlabicz J., (red.), *Prawo własności intelektualnej*, Wolters Kluwer, Warszawa 2018
4. Skubisz R., (red.), *System prawa prywatnego*, t. 14a i 14b, *Prawo własności przemysłowej*, C.H. Beck, Warszawa 2017